

2023 Advanced Materials Characterization Workshop

June 6 and 7 Materials Research Laboratory – University of Illinois at Urbana-Champaign Registration required – only \$80 <u>http://go.illinois.edu/amc2023</u>

Tuesday, June 6		
8 am	Registration and coffee / breakfast (MRL 2 nd floor Main Hallway)	
8:40	Welcome and introduction to MRL (ESB 190)	
9	Tutorial 1: Atom probe tomography Tim Spila, MRL, University of Illinois	
9:30	Tutorial 2: Optical and spectroscopic characterization (I) Julio Soares, MRL, University of Illinois	
10	Coffee Break	
10:30	Tutorial 3: Optical and spectroscopic characterization (II) Julio Soares, MRL, University of Illinois	
11	Tutorial 4: Atomic force microscopy Kathy Walsh, MRL, University of Illinois	
12	Lunch	
1 pm	" This is going to be rough " <i>Luke Vajdic,</i> Keyence	
1:20	"Ultra-high purity conditions for nitride growth with low Oxygen content by plasma-enhanced atomic layer deposition" Sean Armstrong, Kurt J. Lesker Co.	
1:40	Tutorial 5: X-ray photoelectron spectroscopy Rick Haasch, MRL, University of Illinois	
2:30	Coffee Break	
3:00	"Advanced Atomic Force Microscopy for Semiconductor, Battery, and Ferroelectrics Applications" Ted Limpoco, Oxford Instruments	
3:20	"A novel ion source for Lithium-ion microscopy and 3D tomography" Joseph Klingfus, Raith	
3:40	"Make, look, measure: scientific instrumentation from Quantum Design" Rick Hapanowicz, Quantum Design	
4	Tutorial 6: X-ray analysis Mauro Sardela, MRL, University of Illinois	
5 –6:30	Reception and networking (MRL 2 nd floor Main Hallway)	

All presentations are in Room 190 ESB (Engineering Sciences Building Auditorium)



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Wednesday, June 7		
8 am	Coffee / Breakfast (MRL 2 nd floor)	
8:30	Tutorial 7: Rutherford backscattering Tim Spila, MRL, University of Illinois	
9	Tutorial 8: Scanning electron microscopy & focused ion beam Jade Wang, MRL, University of Illinois	
10	Coffee Break	
10:30	"NanoSIMS: A Technique for Advanced Energy Materials Characterization" Matt Pietrucha, CAMECA	
10:50	<i>Tutorial 9:</i> Nanoindentation Jessica Spear, MRL, University of Illinois	
11:20	Tutorial 10: "Transmission electron microscopy (I)" Wacek Swiech, MRL, University of Illinois	
12	Lunch	
1 pm	"The latest dual beam technology advancements in 2023" Rick Passey, ThermoFisher	
1:20	Tutorial 11: "Characterization of soft materials and polymers" Roddel Remy, MRL, University of Illinois	
2:10	Coffee Break	
2:50	Tutorial 12: Biomaterials and cryo-EM Kristen Flatt, MRL, University of Illinois	
3:35	Tutorial 13: Transmission electron microscopy (II) Honghui Zhou, MRL, University of Illinois	
4 – 5	MRL lab tours (meet at MRL 2 nd floor Main Hallway)	

All presentations are in Room 190 ESB (Engineering Sciences Building Auditorium) Vendors' exhibit show: June 6, 9 am-6 pm, and June 7, 9 am-3 pm on the MRL 2nd floor main hallway. <u>Platinum sponsors</u>: CAMECA, Keyence, Kurt J Lesker, Oxford, Quantum Design, Raith, ThermoFisher. <u>Sponsors</u>: JA Woollam, JEOL, Rigaku, Samco, Teledyne/Princeton, Tescan.



Go to <u>http://go.illinois.edu/amc2023</u> or scan this QR code for registration and more details.